

LIST OF ART CITED BY APPLICANT  
(PTO-1449)

ATTY. DOCKET NO.  
P-0549

APPLN. SERIAL NO.  
10/627,806

APPLICANT(S)  
In-Hwan LEE

FILING DATE  
July 28, 2003

GROUP  
2681 2833

## U.S. PATENT DOCUMENTS

**U.S. PATENT APPLICATION PUBLICATIONS**

| SEARCHED, SERIALIZED, INDEXED, AND PUBLISHED IN THE PATENT APPLICATION PUBLICATIONS |                               |            |            |       |          |
|---|-------------------------------|------------|------------|-------|----------|
|   | *PATENT<br>APPLN.<br>PUB. NO. | *PUB. DATE | *APPLICANT | CLASS | SUBCLASS |
|   |                               |            |            |       |          |
|   |                               |            |            |       |          |

**U.S. PATENT APPLICATIONS**

| SEARCH INVENTOR APPLICATIONS |                |                 |           |       |          |  |
|------------------------------|----------------|-----------------|-----------|-------|----------|--|
|                              | *APPLN.<br>NO. | *FILING<br>DATE | *INVENTOR | CLASS | SUBCLASS |  |
|                              |                |                 |           |       |          |  |
|                              |                |                 |           |       |          |  |
|                              |                |                 |           |       |          |  |

## FOREIGN PATENT DOCUMENTS

| EXAMINER'S INITIALS | FOREIGN PATENT DOCUMENTS |           |                            |       |          | Translation<br>Yes      No |
|---------------------|--------------------------|-----------|----------------------------|-------|----------|----------------------------|
|                     | PATENT NO.               | DATE      | COUNTRY                    | CLASS | SUBCLASS |                            |
| <i>dm</i>           | JP2000-231974            | 8/22/2000 | JAPAN (Full Japanese Text) |       |          | Abst. only                 |
|                     |                          |           |                            |       |          |                            |
|                     |                          |           |                            |       |          |                            |
|                     |                          |           |                            |       |          |                            |
|                     |                          |           |                            |       |          |                            |
|                     |                          |           |                            |       |          |                            |

**OTHER ART (Including Author, Title, Date, Pertinent Pages, Publisher, Place of Publication, Etc.)**

*✓* Chinese Office Action dated November 19, 2004

**EXAMINER**

**DATE CONSIDERED**

6/105

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.